*	Application No.	Applicant(s)
Interview Summary	09/938,611	FUNAYAMA ET AL.
	Examiner	Art Unit
	Tianjie Chen	2652
All participants (applicant, applicant's representative, l	PTO personnel):	
(1) <u>Tianjie Chen (Primary Examiner, PTO)</u> .	(3)	
(2) Remus F. Fetea (Representative).	(4)	
· Date of Interview: 19 February 2004.		
Type: a)☐ Telephonic b)☐ Video Conference c)☑ Personal [copy given to: 1)☐ applican		/e]
Exhibit shown or demonstration conducted: d) Ye If Yes, brief description:	s e)⊠ No.	
Claim(s) discussed: 1.		
Identification of prior art discussed: <u>Hayashi et al (US</u>	<u>6,490,139)</u> .	
Agreement with respect to the claims f)☐ was reache	d. g)□ was not reached. h)⊠	N/A.
Substance of Interview including description of the ger reached, or any other comments: After discussion, Rethe relationship among the insulation layer, yokes and defined the Hayashi et al's refence will be overcome. A search to determin the patentability. (A fuller description, if necessary, and a copy of the anallowable, if available, must be attached. Also, where allowable is available, a summary thereof must be attached.	presentative proposes to rephase MR element. Examiner's position As an Official amendment is submined and mental which the examiner as no copy of the amendments that	the language to better define is: if it has been clearly nitted, Examiner will do further
THE FORMAL WRITTEN REPLY TO THE LAST OFFICINTERVIEW. (See MPEP Section 713.04). If a reply to GIVEN ONE MONTH FROM THIS INTERVIEW DATE, FORM, WHICHEVER IS LATER, TO FILE A STATEME Summary of Record of Interview requirements on rever	o the last Office action has already OR THE MAILING DATE OF THE ENT OF THE SUBSTANCE OF THE	y been filed, APPLICANT IS IS INTERVIEW SUMMARY
	<i>:</i>	
	Chem	Timpe 19/04
Examiner Note: You must sign this form unless it is an Attachment to a signed Office action.		nature, if required

BEFORE THE OFFICE OF ENROLLMENT AND DISCIPLINE UNITED STATE PATENT AND TRADEMARK OFFICE

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Expires: April 30, 2004

Harry J. Moatz

Director of Enrollment and Discipline